## INFORMATION DISCLOSURE CITATION IN AN APPLICATION

SEP 1 5 1999

**U.S. PATENT DOCUMENTS** \*EXAMINER REF **SUBCLASS** FILING DATE **DOCUMENT** DATE **CLASS** NAME INITIAL NO. APPROPRIATE NOV 2.5 5,728,324 3/17/98 Welch et al. Ā 264 1/31/95 5,825,741 В 10/20/98 | Welch et al. 369 112 7/10/96 5,575,962 11/19/96 Takahashi C 264 2.5 12/2/94 D 4/8/97 5,618,474 Liau et al. 264 1.1 9/27/94 E 5,218,471 6/8/93 Swanson et al. 359 565 12/2/91 5,348,616 9/20/94 Hartman et al. 156 643 5/3/93 G 4,737,447 4/12/88 Suzuki et al. 430 321 6/9/86 H 5,837,156 11/17/98 Cumming 249 119 9/30/96 5,876,642 3/2/99 Calderini et al. 264 2.5 1/31/96 2,745,138 26 5/15/56 Beattie 18 5/26/53  $\overline{\mathsf{K}}$ 4,874,561 10/17/89 Spector 264 1.1 3/3/88 4,840,754 264 2.2 6/20/89 Brown et al. 11/9/87 М 4,751,029 6/14/88 Swanson 264 40.4 10/22/86 HOV FOREIGN PATENT DOCUMENTS REF DATE **DOCUMENT COUNTRY** CLASS SUBCLASS Translations NO. OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) T. Fujita et al., "Blazed gratings and Fresnel lenses fabricated by electron-beam DUD V lithography", OPTICS LETTERS, Vol. 7. No. 12, Dec. 1982, pages 578-580.

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